

Fig. 1 Growth rate of PI on Cu and Si versus deposition temperature.

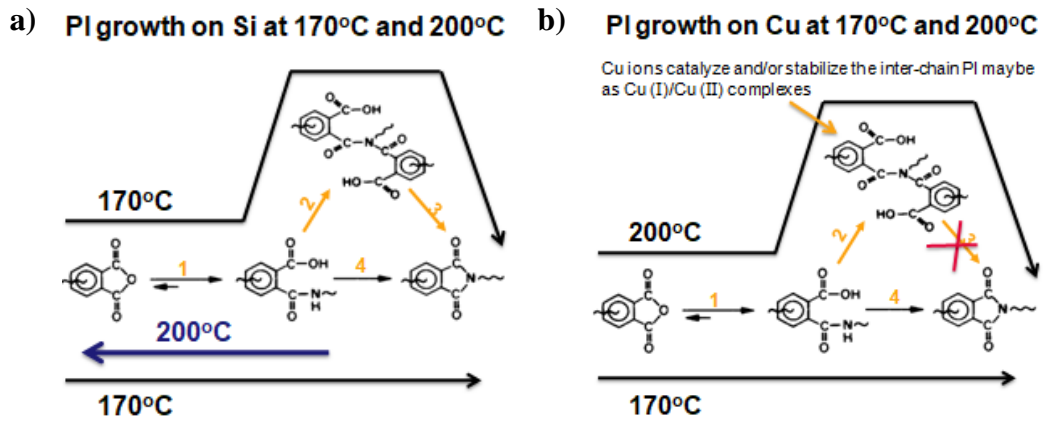


Fig. 2 Schematic diagram of surface reaction between PMDA and DAH to form a) cyclic PI on Si and b) both cyclic and inter-chain PI on Cu at 170 and 200 °C.